

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/027,992
Filing Date December 19, 2001
Inventor Janine K. Kardokus et al.
Assignee Honeywell International Inc.
Group Art Unit 1742
Examiner Kastler, Scott R.
Attorney's Docket No. JM34006DIV
Title: Methods of Forming Copper-Containing Sputtering Targets



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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TC 1700

To: Commissioner for Patents
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From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: 12-29-2003

By: _____

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

01/07/2004 ZJU HAR1 00000054 10027992

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. JM34006D1V		SERIAL NO. 10/027,992	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Janine K. Kardokus et al.			
				FILING DATE December 19, 2001		GROUP 1742	

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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA 6,440,243 B1	08-2002	Tan et al.				
	AB 6,277,254 B1	08-2001	Tan et al.				
	AC 3,766,642	10-1973	Schlaudi et al.				
	AD 6,451,135	09-2002	Takahashi				
	AE 6,478,902B2	11-2002	Koenigsmann et al.				
	AF 6,579,467 B2	06-2003	Li et al.				
	AG 6,451,222 B1	09-2002	Li et al.				
	AH 5,435,826	07-1995	Sakakibara et al.				
	AI 5,486,491	01-1996	Sengupta et al.				
	AJ 5,312,790	05-1994	Sengupta et al.				
	AK						
	AL						

O I P E
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 PATENT & TRADEMARK OFFICE

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AM 11323539	11-1999	Japan					
AN 0441408A2	08-1991	EPO					
AO EP1026284A1	09-2000	EPO					
AP JP2000239836A	09-2000	Japan					
AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)		
AR		Yeon et al., "Electrical Characteristics of the MOD-derived SrBi2xTa2O9 and SrBi2.4(TA,Nb)2O9 Thin Films", Journal of Materials Science, 35(10), pgs. 2405-2411, May 15, 2000. Abstract only.
AS		Yan et al., "Preparation on the [(Pb,La) (Zr,Ti)O3] Ferroelectric Thin Films by Using the Sol-Gel Processing", Piezoelectrics and Acoustooptics, Volume 17, issue n 5, October 1995, pgs. 24-27.
AT		

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.